

## **High Efficiency Triple Well Charge Pump Circuit**

This application claims priority to Provisional Patent Application serial number 60/424,252, filed on November 6, 2002, which is herein incorporated by reference

### **BACKGROUND OF THE INVENTION**

#### **1. Field of Invention.**

The present invention relates to integrated circuits and more specifically to charge pump circuits providing high output voltage and current at low power supply voltages.

#### **2. Description of related art.**

A charge pump is widely used in semiconductor memories, and in particular non-volatile Electrically Erasable and Programmable Read Only Memories (EEPROM) where a voltage larger than the supplied chip voltages, such as 3.3V, 2.5V is generally required up to 10V or more. These high voltages are typically not available on the chip so they are generated from the low supplied voltage. These higher voltages are mainly required in such operations as programming and erase of a memory cell. As the power supply voltage to the chip is reduced down in the range of 1.2 to 1.8 volts and below as seen in recent mobile applications, voltages higher than the power supply voltage may be required for read operations of non-volatile memories to maintain read performance. Thus there is an increasing demand for low voltage driven charge pumps that can produce a high output voltage and current.

US Patent 6,418,040 B1 (Meng) is directed to a cross coupled charge pump that can provide a high positive or negative or negative output voltage depending upon which state the two input voltages of the charge pump are used. In US Patent 6,212,107 B1 (Tsukada) a charge pump is directed to providing a stepped voltage and includes a leakage current suppression circuit. US Patent 6,130,574 is directed to providing a negative voltage charge pump, wherein each stage contains three or four MOS transistors and has two clocks operating at different phases. US Patent 6,046,625 is directed to providing a charge pump circuit having multiple mirrored stages that are controlled by logic circuitry that receives a clock signal and an enable signal. In US Patent 5,925,905 (Hanneberg et al.) a MOS circuit configuration is directed to a high voltage charge pump without using deep insulating wells. In US Patent 5,815,026 a charge pump circuit is directed to providing a high voltage low current at a high efficiency.

A conventional charge pump circuit based on a diode structure is discussed in "On-Chip High-Voltage Generation in NMOS Integrated Circuits Using Improved Voltage Multiplier Technique", IEEE Journal of Solid-State Circuits, Vol. 11, No. 3, June 1976, pp 374-378. As shown in FIG. 1, the charge pump includes a plurality of pumping stages that are serially connected between supply voltage VDD and the output voltage Vpp. The supply voltage VDD is connected through a source device Ma to the series connections of charge transfer MOS devices Mb, which produce a high voltage output Vpp. The substrate regions of the charge transfer MOS devices Mb are held at ground. Each stage is clocked through a storage capacitor C with a clock signal P1 or P2 that are at a different phase as shown in Fig. 2. Each of these clock signals provides a high

level of VDD power supply voltage and a low level of ground. The clocks are phased such that charge is transferred to the output of the first stage while the second stage is held off and then the first stage is held off while the charge from the first stage is clocked to output of the second stage. This alternate clocking of adjacent stages continues through the remainder of the serially connected charge pump circuit. The technique of prior art has been widely used, but suffers from degradation in threshold voltage of charge transfer MOS devices during its operation. The voltage between the source and substrate regions of each charge transfer MOS device Mb gradually increases during operation, which results in increasing of the effective threshold voltage of the charge transfer MOS devices Mb in each pump stage. This effect is often referred to as 'Body effect'.

In general, the output voltage of conventional charge pump circuit, Vout can be expressed as,

$$V_{out} = VDD - V_{th}(V_{sb}) + \sum_{i=1}^N [\alpha VDD - V_{th}(V_{sb})]$$

where  $V_{th}(V_{sb})$  is threshold voltage of MOS device including body effect, VDD is power supply voltage, and N is number of stages. The  $\alpha$  is boost coupling ratio at each node and can be given by

$$\alpha = \left( \frac{C_b}{C_b + C_p} \right)$$

where  $C_b$  and  $C_p$  are boost coupling capacitance and stray parasitic capacitance, respectively. As a result the maximum output voltage of the conventional charge pump

circuit is limited and the efficiency decreases as the number of stages increase, especially for low power supply voltage.

New techniques have been proposed to overcome the problems of the conventional charge pump circuit. A representative charge pump circuit of prior art using a four-phase clock scheme which is described in "A 5V Only 0.6um Flash EEPROM with Row Decoder Scheme in Triple Well Structure", IEEE Journal of Solid State Circuits, Vol. 27, No. 11, November 1992, pp 1540-1545, is shown in FIG. 3. The charge pump circuit includes a number of stages of a charge transfer MOS device  $M_t$  and an auxiliary MOS device  $M_g$  which is used to precharge the gate terminal of the charge transfer MOS device  $M_t$  for high boosting gate effect. The substrate regions of the charge transfer MOS devices  $M_t$  are held at ground. A supply voltage  $V_{DD}$  is applied to a drain of a charge transfer MOS device  $M_t$  and an auxiliary MOS device  $M_g$  in the first stage. In subsequent stages the output of the previous stage is connected to the source of the charge transfer device  $M_t$ , the auxiliary MOS device  $M_g$ . There are two capacitors in each stage  $C_g$  and  $C_b$ , which are connected to different clocks, P2 and P3 for the first stage and P4 and P1 for the second stage. The four individual clocks, P1, P2, P3, and P4 are shown in Fig. 4. The clocks are phased such that charge is transferred to the output of the first stage while the second stage is held off and then the first stage is held off while the charge from the first stage is clocked to output of the second stage. This alternate clocking of adjacent stages continues through the remainder of the serially connected charge pump circuit.

A prior art charge pump circuit using a floating well is described in US 5,986,947 (Choi et al.). The charge pump circuits using a triple well P-N junction and MOS diodes

are disclosed in "A 3.3V only 16Mb DINOR flash memory", IEEE International Solid State Circuits Conference, Digest of Technical Papers, 1995, pp 122-123, and in US 6,100,557 (Hung et al.), respectively. The triple well charge pump provides greater efficiency with increased suppression of the body effect over other prior art. This improvement is due to the extra diode inherently formed between the well and the source of the charge transfer MOS device that can help increase the forward conduction current.

In FIG. 5 is shown a diagram of a cross sectional view of a charge pump circuit of prior art in a triple well. The drain of the charge transfer MOS device  $M_t$  is connected to the P-well and the deep N-well. This allows a parasitic capacitor between the P-well and the deep N-well and a parasitic capacitor between the deep N-well and the P-substrate. The P-well and the deep N-well consume more silicon area than the charge transfer MOS device creating large junction capacitors and diodes. There are two more parasitic diodes formed at the junctions of the source and drain of the charge transfer MOSFET device and the P-well. These diodes are much smaller than those of the P-well to deep N-well and deep N-well and the P-substrate and are omitted from the diagrams. The diodes for the P-well and the deep N-well,  $D_{pw}$  and  $D_{nw}$ , are shown in the schematic of FIG. 6.

The parasitic capacitance of the P-well and the deep N-well negatively affects the boosting voltage coupled to the drain of the charge transfer MOS device when the boosting clock signal is on. The parasitic diodes  $D_{pw}$  and  $D_{nw}$  provide a reverse bias leakage current from the drain node of the charge transfer MOS device to the P-substrate that is connected to ground. These two effects cause a degradation of

efficiency of the charge pump circuit, especially at low power supply voltages. Since the parasitic junction capacitance and the leakage current of the parasitic diode are layout dependent, the output characteristics of the conventional triple-well charge pump circuit is easily affected by layout and process variations.

### SUMMARY OF THE INVENTION

It is an objective of the present invention to provide a higher boosted voltage and current output using a low power supply operation and within a small layout area.

It is further an objective of the present invention to provide a multi-stage charge pump circuit in which each stage delivers a higher voltage and current to the subsequent stage.

It is also an objective of the present invention to provide MOSFET devices within a triple well of each stage of the multi-stage charge pump circuit.

It is also an objective of the present invention to provide a charge transfer and auxiliary MOSFET devices within a same P-well contained within a deep N-well of each stage of the multi-stage charge pump circuit.

It is also an objective of the present invention for each stage of the multi-stage charge pump to contain a deep N-well that is electrically isolated from the deep N-well of other stages.

It is further an objective of the present invention to electrically isolate the drain of the charge transfer MOSFET from the parasitic capacitance of the P-well and deep N-well within which the P-well resides.

It is still further an objective of the present invention to provide a boosted voltage at the gate of the charge transfer MOSFET device by a boost coupling capacitor increased by an auxiliary MOSFET device connected to the source node of the charge transfer device.

It is still further an objective of the present invention to reduce the body effect to the charge transfer MOSFET device by the transfer of the boosted source voltage by an auxiliary MOSFET device to the P-well and N-well of each stage, which is then floated when the auxiliary device is turned off.

It is also further an objective of the present invention to drive the multi-stage charge pump with a four-phase clock.

It is still further an objective of the present invention allow the multi-stage charge pump circuit to be driven by a two-phase clock.

In the present invention a charge pump circuit is disclosed that has multiple stages connected in series. In each stage there are three MOSFET devices residing in a P-well within a deep N-well unique to each stage and on a P-substrate. The three MOSFET devices of each stage comprise one charge transfer device, one auxiliary MOSFET device for pre-charging a voltage on the gate of the charge transfer device and one auxiliary MOSFET device for buffering the drain of the charge transfer device from the P-well and the deep N-well. Each stage also contains two boost capacitors needed to store charge as it is developed. Each stage is clocked by two clock signals

that are out of phase with each other. The serial connected stages are clocked such that the corresponding clocks signals for adjacent stages are out of phase with each other. Thus, a four clock system is used; however, with the proper arrangement of two clock signals, a two clock system can also be used. When charge is being clocked into a first stage, pumped charge is being clocked into a third stage from the second stage.

The auxiliary device, which is used for pre-charging a voltage on the gate of the charge transfer device, couples the input signal of each stage to the gate of the charge transfer device; and therefore, increases the boost coupling effect on the charge transfer MOS device, which results in increasing a signal level at the source (output) of the charge transfer device. The auxiliary device, that is used for buffering the drain of the charge transfer device from the P-well and the N-well, couples the drain voltage of the charge transfer device to the P-well and the deep N-well to reduce the body effect and to improve capacitive coupling effect on the drain of charge transfer MOSFET device by reducing the effects of the P-well and Deep N-well parasitic capacitance.

It should be noted that although the present invention has been oriented to a charge pump circuit formed from N-channel MOSFET devices in a P-well within a deep N-well on a P-substrate, a similar charge pump circuit could be formed from P-channel MOSFET devices in an N-well within a deep P-well residing on an N-substrate.



**BRIEF DESCRIPTION OF THE DRAWINGS**

This invention will be described with reference to the accompanying drawings, wherein:

FIG. 1 is a circuit diagram of a conventional charge pump circuit of prior art,

FIG. 2 is a diagram showing a two-phase clock that is used in the prior art of FIG.1,

FIG. 3 is a circuit diagram of a charge pump circuit of prior art using a four-phase clock system,

FIG. 4 is a diagram showing a four-phase clock that is used in the prior art of FIG.3,

FIG. 5 is a cross section diagram of a charge pump circuit stage of the prior art using a triple well in each stage,

FIG. 6 is a circuit diagram of a charge pump circuit of prior art of FIG. 5,

FIG. 7 is a circuit diagram of the charge pump circuit of the present invention,

FIG. 8 is a diagram showing a two-phase clock that is used in the present invention,

FIG. 9 is a cross section diagram of a charge pump circuit stage of the present invention of FIG. 7,

FIG. 10 is an output voltage of the present invention and conventional charge pump circuits as number of stage increases,

FIG. 11 is a circuit diagram of an alternative charge pump circuit of the present invention,

FIG. 12 is a cross section diagram of a charge pump circuit stage of the present invention for generating a negative high voltage output, and

FIG. 13 is a circuit diagram of a negative voltage charge pump circuit of the present invention.

### DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

FIG. 7 shows a circuit diagram of the charge pump of the present invention where the negative effects of the triple well are reduced by the inclusion of the auxiliary MOSFET device Ms. Included in the circuit diagram are Dpw, the parasitic diode between the P-well and the deep N-well, and Dnw, the parasitic diode between the deep N-well and the P-substrate. Other, and less important, parasitic diodes and capacitances associated with MOS devices are not shown for ease of understanding of the circuit diagram. Pumping stages are connected in series from power supply VDD to the high voltage output Vpp. Each pumping stage is formed in its own P-well and deep N-well. The P-well acts as substrate region of the MOS devices in the pumping stage.

Each pumping stage includes three N-channel MOSFET devices, a charge transfer MOS device Mt, an auxiliary MOS device Mg to pre-charge a voltage on the gate of the charge transfer device Mt for increasing boost coupling effect, and an auxiliary device Ms that couples a boosted drain potential of the charge transfer MOS

device to the P-well and the deep N-well to switch the coupling between the charge transfer MOS device and the substrate region, thus increasing boost coupling effect and reducing the body effect on the charge transfer MOS device. Also there are two boost-coupling capacitors,  $C_g$  and  $C_b$ . It also includes a plurality of stages each having the same formation as represented by the first stage. The input to the first stage is the power supply voltage  $V_{DD}$ , and the input of each subsequent stage is the output voltage of the previous stage delivered from the source of the charge transfer device of the previous stage. The output of the final stage produces a voltage  $V_{pp}$  that has been pumped up to a higher voltage than the power supply voltage.

Continuing to refer to FIG. 7, an input voltage of a stage is applied to the drain of the charge transfer MOS device  $M_t$  within the stage. This same input voltage is coupled to the gate of the charge transfer MOS device  $M_t$  by means of an auxiliary MOS device  $M_g$  and clock signal  $P_3$  in odd numbered stages and clock signal  $P_1$  in even number stages. Similarly, a boosted input signal to a stage is coupled to the P-well  $D_{pw}$  and deep N-well  $D_{nw}$  by the auxiliary MOS device  $M_s$ , which is gated by the gate signal of the charge transfer MOS device  $M_t$ . Clock  $P_2$  for odd numbered stages and clock  $P_4$  for even number of stages are applied to the gate of the charge transfer MOS device through capacitor  $C_g$ .

The conventional four-phase clock system shown in FIG. 4 can be used in the circuit of the present invention. The conventional two-phase clock system can also be used in the present invention circuit by arranging two clocks properly, as shown in FIG. 8. The use of a two phase clock is realized by pairing clocks  $P_1$  and  $P_2$  together and clocks  $P_3$  and  $P_4$  together.

The operation of the circuit of the present invention shown in FIG. 7 using a two clock scheme is described with respect to Stage (2). The pumping operation of other stages is carried out in a similar manner. During the first-clock phase, auxiliary MOS device Mg is turned on by the clock P1 so that the gate voltage of the charge transfer MOS device Mt is precharged at a charge shared voltage with a high voltage from the drain node of the MOS device Mt. At the same time, the drain of the charge transfer MOS device Mt is decoupled from P-well and deep N-well because the auxiliary MOS device Ms is off and the body of the pumping stage is floated with a voltage. Then, during second clock phase, the auxiliary MOS device Mg is off and the clocks P3 and P4 couple the drain and gate node of charge transfer MOS device Mt to a high voltage level. Because of the decoupling of the charge transfer device from the parasitic capacitances associated with the P-well and deep N-well, the drain voltage can be efficiently boosted by the clock. Then the charge transfer MOS device Mt and the auxiliary MOS device Ms are simultaneously turned on by clock P4, and the body voltage of the pumping stage is coupled to the drain node of the charge transfer MOS device Mt through the auxiliary MOS device Ms. The charge transfer MOS device Mt passes a boosted high voltage at its drain to the input of next stage without a effective threshold voltage loss due to body effect. This allows it to provide more voltage and current at the output so that the charge pump circuit can be implemented in fewer stages, which results in less silicon die area.

In FIG. 9 is shown a cross section view of a portion of the circuitry in a stage of the multi-stage charge pump circuit shown in FIG.7, which includes the charge transfer MOS device Mt and the auxiliary MOS device Ms. Not shown in FIG. 9 is the auxiliary

MOS device Mg. The MOS devices Mt and Mg are shown in a P-well within the deep N-well of a stage of the charge pump residing on a P-substrate. An input charge pump voltage from a previous stage is connected to the drain D1 of the charge transfer N-channel MOSFET device Mt and the drain D2 of the auxiliary N-channel MOSFET device Ms. The source S2 of the auxiliary MOSFET device Ms is connected to both the P-well and the deep N-well. A pump clock signal is connected to the gates of the charge transfer MOS device Mt and the auxiliary MOS device Ms through a coupling capacitor Cg (not shown). The output of the stage is taken from the source S1 of the charge transfer MOS device Mt and besides being connected to the next stage, the output is connected to a coupling capacitor Cb (not shown) as well as the gate of the auxiliary MOS device Mg (not shown). The auxiliary MOS device Mg is also located within the same P-well as the charge transfer MOS device Mt and the auxiliary MOS device Ms. From this cross section it is demonstrated how the auxiliary MOS device Ms buffers the drain D1 of the charge transfer MOS device Mt from the P-well and the deep N-well. The input voltage at the drains D1 and D2 of the charge transfer MOS device Mt and the auxiliary MOS device Ms, respectively, is coupled to the P-well and the deep N-well by the auxiliary MOS device Ms controlled by the gate control signal, which is formed from the auxiliary MOS device Mg and the P2 or P4 clock signals at the gate of the charge transfer MOS device Mt schematically shown in FIG. 7. Therefore, the P-well and the deep N-well see a voltage similar to the voltage produced at the input of the charge transfer MOS device Mt when the charge transfer MOS device Mt is turned on. This allows the P-well and the Deep N-well to have a voltage similar to the source S1 of the charge transfer MOS device Mt when it is turned on so that the charge transfer MOS

device  $M_t$  is able to transfer a boosted high voltage from the input to the output without any voltage loss caused by the body effect. The silicon area penalty resulting from the auxiliary MOS devices  $M_g$  and  $M_s$  can be negligible because their area is small compared to the charge transfer MOS device  $M_t$  and coupling capacitors  $C_b$  and  $C_g$ .

FIG. 10 shows a simulated output voltage of the charge pump circuit of present invention as a function of number of stages for power supply voltages  $V_{DD}=1.2V$  (curve  $Pi2$ ) and  $V_{DD}=1.8V$  (curve  $Pi1$ ). The conventional MOS diode charge pump circuit is also plotted for comparison for power supply voltages  $V_{DD}=1.2V$  (curve  $Ci2$ ) and  $V_{DD}=1.8V$  (curve  $Ci1$ ). Two-phase clocks system is used and the frequency of clock is 15MHz. The channel length of all MOS devices is 0.6 $\mu m$  and the channel width of charge transfer MOS device and auxiliary MOS devices is 35 $\mu m$  and 3 $\mu m$ , respectively. The capacitance of the coupling capacitors  $C_b$  and  $C_g$  are 1.5pF and 0.6pF, respectively. A 5pF capacitor is used as an output load. According to the results of the simulation, the present invention circuit outperforms the conventional charge pump circuit, especially as the number of stage increases.

FIG. 11 shows a second embodiment of charge pump circuit diagram of the present invention. The basic components of the charge pump circuit are as same as the first embodiment of the present invention shown in FIG. 7, except that there is a pull-down N-channel MOSFET device  $M_d$ . The charge pump circuit includes the charge transfer MOS device  $M_t$ , the auxiliary MOS device  $M_g$ , and auxiliary MOS device  $M_s$  contained within the same P-well inside a deep N-well for each stage. The pull-down MOS device  $M_d$ , however, can be formed either on the same P-well inside a deep N-well or on the P-substrate. The drain and gate of the pull down device  $M_d$  are

connected to the gate of the charge transfer device  $M_t$ , and the source of the pull-down device  $M_d$  is connected to the output of the pumping stage. The pull-down MOS device  $M_d$ , which is connected as a diode, is used to prevent back flow of charge from the output to the input of the pumping stage in a situation when the gate voltage of charge transfer device  $M_t$  becomes high enough to turn on the charge transfer device  $M_t$  (even weakly) and when the clock signal coupled to the gate of the charge transfer device  $M_t$  changes from high level of VDD to low level of ground. When this situation occurs during operation, the pull-down MOS device  $M_d$  keeps the charge transfer device  $M_t$  turned off which results in preventing the back flow of the charge from the output to the input of the pumping stage.

A negative high voltage output charge pump circuit can also be realized using the same triple-well structure of the present invention, except that deep N-well is connected to  $V_{dnw}$ , which is a positive voltage and can be either the power supply VDD, or ground. FIG. 12 shows a cross-sectional view of the charge pump circuit of present invention for a negative high voltage output. The charge transfer MOS device  $M_t$  and auxiliary MOS device  $M_s$  are formed in their own P-well which act as substrate of the MOS devices. The deep N-well can be shared with other pumping stages and connected to ground or power supply VDD. The source  $S_2$  and drain  $D_2$  of the auxiliary MOS  $M_s$  are coupled to the P-well and the drain  $D_1$  of the charge transfer MOS device  $M_t$ , respectively. The drains  $D_1$  and  $D_2$  and the gates of the charge transfer device  $M_t$  and auxiliary device  $M_s$  are coupled together and are further connected to the coupling capacitor  $C_b$ .

FIG. 13 is a circuit diagram of an embodiment of the present invention of a charge pump for generating a negative voltage output. The circuit uses an N-channel MOSFET as charge transfer device  $M_t$  and an auxiliary device  $M_s$ . The pumping stages are connected in series from ground to the negative output voltage  $(-V_{pp})$ . Each pumping stage includes one charge transfer MOS device  $M_t$ , one auxiliary MOS device  $M_s$  and one coupling capacitor  $C_b$ . The P-well within each pump stage, Stage (1), Stage (2), Stage (3), Stage (n-1) and Stage (n), resides within a deep N-well and isolates the circuitry of each stage. The deep N-well can be common for each P-well or separate for each P-well. The auxiliary device  $M_s$  couples a boosted voltage to the P-well to reduce body effects on the pumped voltage within each stage. The diode  $D_{pw}$  represents the parasitic diode junction between the P-well and the deep N-well. A positive voltage  $V_{dnw}$ , which can be either VDD or ground, is applied to the deep N-well to insure that the diode  $D_{pw}$  remains back biased throughout the negative charge pump operations.

The circuit operation of the negative charge pump is carried out in the same manner as the positive charge pump circuit, except that the input of the charge pump circuit is coupled to the ground, instead of VDD. A two clock scheme using clocks P1 and P3, or P2 and P4, shown in FIG. 8 for the positive charge pump circuit can be used for the negative charge pump circuit. When the charge transfer MOS device  $M_t$  in a first pump stage is turned on by a clock signal, a boosted negative charge is created at the output of a first pump stage, which is coupled to the drain nodes of the charge transfer MOS device  $M_t$  and auxiliary MOS device  $M_s$ . The boosted negative charge is transferred to the input of a second pump stage connected to the output of the first



pump stage. The boosted negative charge is coupled to a source of the charge transfer MOS device  $M_t$  in the second stage. At the same time, the auxiliary MOS device  $M_s$  of the first stage is also turned on so that the boosted negative charge of the output of the first pump stage is coupled to the P-well of the first pump stage. The coupling of the boosted negative charge to the P-well reduces the body effect on the charge transfer MOS device  $M_t$ , which results in an increased charge transfer efficiency.

While the invention has been particularly shown and described with reference to preferred embodiments thereof, it will be understood by those skilled in the art that various changes in form and details may be made without departing from the spirit and scope of the invention.

What is claimed is: